

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. ....10/293,072  
Priority Filing Date .....November 12, 2002  
 Inventor ..... Trung Tri Doan, et al.  
 Assignee .....Micron Technology, Inc.  
Priority Group Art Unit ..... 2812  
Priority Examiner ..... Jennifer M. Kennedy  
 Attorney Docket No. .... MI22-2359  
 Title ..... Atomic Layer Deposition Methods

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

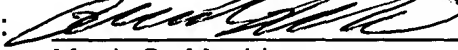
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 10/293,072, filed November 12, 2002. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 7-28-03

By:   
 Mark S. Matkin  
 Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2359		SERIAL NO. 10/293,072 (priority)	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Trung Tri Doan, et al.			
				FILING DATE November 12, 2002 (priority)		GROUP 2812 (priority)	

U.S. PATENT DOCUMENTS							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,200,893 B1	3/13/01	Sneh	438	685	
	AB	6,343,565 B1	2/5/02	Hongoh	118	723	
	AC	6,355,561 B1	3/12/02	Sandhu, et al.	438	676	
	AD	6,369,763 B1	4/9/02	Norris, et al.	343	701	
	AE	6,399,520 B1	6/4/02	Kawakami, et al.	438	778	
	AF	10/293,025		Blalock, et al. (as filed)			11/2/02
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AJ						
	AK						
	AL						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AM		Yamamoto, et al. – Design of Radial Line Slot Antennas at 8.3 GHz for Large Area Uniform Plasma Generation	
EXAMINER		DATE CONSIDERED	

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.